

Docket No.: 3273-0221PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yo YAMATO et al.

Application No.: 10/572,548

Confirmation No.: 7436

Filed: March 17, 2006

Art Unit: 1794

For: POROUS FILMS WITH CHEMICAL
RESISTANCE

Examiner: V. S. Chang

**STATEMENT OF SUBSTANCE OF INTERVIEW IN
ACCORDANCE WITH MPEP §713.04**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

Applicants thank the Examiner for the time, helpfulness and courtesies extended to Applicants' representative during the Interview of June 18, 2009. The assistance of the Examiner in advancing prosecution of the present application is greatly appreciated. In compliance with M.P.E.P. § 713.04, Applicants submit the following remarks.

The Interview Summary form issued on June 22, 2009 amply summarizes the discussions at the Interview. The outstanding rejection of the claims under 35 U.S.C. 101 and 112, 1st paragraph was discussed. The Examiner acknowledged that the proposed amendment (of June 11, 2009) would overcome the rejections of record.


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If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Dated: August 11, 2009

Respectfully submitted,

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